

Slater & Matsil, L.L.P.

Suite 1000
17950 Preston Road
Dallas, Texas 75252-5793
Phone: 972-732-1001 Facsimile: 972-732-9218

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FACSIMILE COVER SHEET

To Examiner: Zeinab El-Arini	Total Pages Sent: 2
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Facsimile Number: (571) 273-8300	Transmission Date: February 7, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ishizaki, *et al.* Docket No.: SCL-003
Serial No.: 10/663,558 Art Unit: 1746
Date Filed: September 16, 2003
TITLE: Apparatus And Method For Substrate Processing

CERTIFICATION OF FACSIMILE TRANSMISSION

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- Certification of Facsimile Transmission (1 page)
- Election (1 page)

Respectfully submitted,

Kristy Engeldahl

Kristy Engeldahl
Legal Assistant

Confirmation Respectfully Requested

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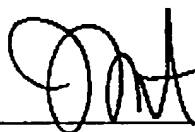
Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on January 13, 2006, Applicant elects claims 1-15, drawn to a substrate processing apparatus, for further prosecution in the above patent application.

Respectfully submitted,



Ira S. Matsil
Attorney for Applicant
Reg. No. 35,272

February 7, 2006

Date

SLATER & MATSIL, L.L.P.
17950 Preston Rd.
Suite 1000
Dallas, TX 75252-5793
972-732-1001 - Tel
972-732-9218 - Fax